

**Notice of References Cited**

Application/Control No.

10/038,419

Applicant(s)/Patent Under  
Reexamination  
CHEN ET AL.

Examiner

Leo B. Tentoni

Art Unit

1732

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,997,741 A	12-1999	Shimoda et al.	264/41X
*	B	US-2003/0176876 A1	09-2003	Chen et al.	606/152
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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